

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

**priority** Application Serial No. .... 10/075,172  
Confirmation No. .... unknown  
**priority** Filing Date ..... February 13, 2002  
Inventor..... B. E. Cron  
Assignee.....Micron Technology, Inc.  
Group Art Unit..... unknown  
Examiner ..... unknown  
Attorney's Docket No. ....MI22-2430  
Customer No: .....021567  
Title: Methods for Conditioning Surfaces of Polishing Pads After Chemical-Mechanical  
Polishing

**PRELIMINARY AMENDMENT**

To: Mail Stop Patent Application  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

From: David G. Latwesen, Ph.D. (Tel. 509-624-4276; Fax 509-838-3424)  
Wells St. John P.S.  
601 W. First Avenue, Suite 1300  
Spokane, WA 99201-3828

**AMENDMENTS**

EV318283274